



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re application of

: **Confirmation No. 2779**

Hiromi OGASAWARA et al.

: Docket No. 2003_0912A

Serial No. 10/616,996

: Group Art Unit 2813

Filed July 11, 2003

: Examiner Jennifer M. Dolan

METHOD OF MANUFACTURING A
SEMICONDUCTOR ELEMENT

Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
August 11, 2004.

The fee of \$1,020.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion
which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Hiromi OGASAWARA et al.

By

Jonathan R. Bowser

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Registration No. 54,574
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JRB/ck

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February 11, 2005